Search Notes



Application/Control No.	Applicant(s)/Patent Under Reexamination
10607020	HILL ET AL.
Examiner	Art Unit
Le Nguyen	2174

SEARCHED				
Class	Subclass	Date	Examiner	
715	752, 963	11/13/07	lvn	
715	752, 963	2/25/2009	lvn	
715	752, 963	6/17/2009	lvn	
715	752, 963	12/30/2009	lvn	
715	752, 963	5/19/2010	lvn	

SEARCH NOTES			
Search Notes	Date	Examiner	
confirmed allowance w/Sy Luu	6/21/07	lvn	
US-PGPub, USPAT: 715/751-753; 709/204-207	11/13/07	lvn	
EPO, JPO	11/13/07	lvn	
ACM library, IEEE Xplore	11/13/07	lvn	
confirmed allowance w/Raymond Bayerl	6/25/07	lvn	
confirmed allowance w/Steve Sax	11/26/07	lvn	
updated search	2/25/2009	lvn	
updated search	6/17/2009	lvn	
updated search	12/30/2009	lvn	
updated search	5/11/2010	lvn	

INTERFERENCE SEARCH				
Class	Subclass	Date	Examiner	
715	752, 963	11/13/07	lvn	
715	752, 963	2/25/2009	lvn	
715	752, 963	6/17/2009	lvn	
715	752, 963	12/30/2009	lvn	
715	752, 963	5/19/2010	lvn	

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